

EXAMINER'S AMENDMENT

An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Mr. Nichols on February 4, 2011.

The application has been amended as follows:

In lines 7-8 of claim 71, "(N,N-Dimethylamino)ethyl methacrylate, 2-N-Morpholinoethyl acrylate, or 3-Dimethylaminopentyl acrylate" has been replaced with --- (N,N-dimethylamino)ethyl methacrylate, 2-N-morpholinoethyl acrylate, or 3-dimethylaminopentyl acrylate ---.

In line 2 of claim 83, "Polymethylmethacrylate" has been replaced with --- polymethylmethacrylate ---.

In line 2 of claim 85, ---further --- has been inserted after "layer".

The following is an examiner's statement of reasons for allowance: US Pat. Ogawa et al (US 5,576,088) teaches the instant print medium substantially in examples in which a heat-treatment of a gloss-providing layer formed on an ink-receiving layer are taught. The purpose of Ogawa et al is to obtain a print medium with a high surface gloss and thus the examiner does not see an elimination of said heat-treatment in order to arrive at the instant print medium with non-fused latex layer.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Tae H. Yoon whose telephone number is (571) 272-1128. The examiner can normally be reached on Mon-Fri.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David Wu can be reached on (571) 272-1114. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

/Tae H Yoon/
Primary Examiner
Art Unit 1762

THY/February 5, 2011

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